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Assistant Commissioner for Patents, Washington, D.C. 20231, on
MARCH 24, 2003
By: Sharon M. Fujita
Sharon M. Fujita

Attorney Docket No: 0123.210US

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Sun Ai Raillard, *et al.*

Examiner: Tomas Friend

Application No.: 09/502,283

Art Unit: 1627

Filed: February 11, 2000

For: HIGH THROUGHPUT MASS SPECTROMETRY

AMENDMENT

Assistant Commissioner for Patents
Washington, D.C. 20231

Sir:

The following amendments and remarks address the rejections raised in the non-final Office Action mailed September 23, 2002. A petition for a three month extension of time authorizing the Commissioner to charge the requisite fee pursuant 37 C.F.R. § 1.17 is enclosed. Thus, the petition effectively extends the period of response from December 23, 2002 to March 24, 2003 (March 23, 2003 falls on a Sunday).

Adjustment date: 04/04/2003 EFLORES
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